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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Heger et al. Examiner : Chen, Kin-Chan  
Serial No. : 10/656,353 Art Unit : 1765  
Filed : September 5, 2003  
For : METHOD FOR DETERMINING THE END POINT FOR A  
CLEANING ETCHING PROCESS

I hereby certify that this paper for S/N 10/656,353 is being facsimile  
transmitted to 571-273-8300 at the United States Patent &  
Trademark Office on the date indicated below:

January 4, 2006

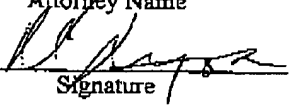
Date of Deposit

Manu J. Teiwani

Attorney Name

37,952

PTO Reg. No.

  
SignatureJanuary 4, 2006

Date of Signature

**REPLY TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 4, 2005, applicants amend  
the claims as listed in the **Claims** section beginning at page 2 of this paper. **Remarks** are  
presented beginning at page 4 of this paper.

NY02:537032.1